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<b>TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT</b> (Under 37 CFR 1.97(b) or 1.97(c))			Docket No. USS-18302/16	
In Re Application Of: Subhendu Guha et al.				
Serial No. 10/765,435	Filing Date January 27, 2004	Examiner	Group Art Unit	
Title: METHOD FOR DEPOSITING HIGH-QUALITY MICROCRYSTALLINE SEMICONDUCTOR APPARATUS				
Address to: Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450				
<b>37 CFR 1.97(b)</b>				
1. <input checked="" type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.				
<b>37 CFR 1.97(c)</b>				
2. <input type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:				
<input type="checkbox"/> the statement specified in 37 CFR 1.97(e);				
OR				
<input type="checkbox"/> the fee set forth in 37 CFR 1.17(p).				



**TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT**  
(Under 37 CFR 1.97(b) or 1.97(c))

Docket No.  
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10/765,435

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January 27, 2004

Examiner

Group Art Unit

**METHOD FOR DEPOSITING HIGH-QUALITY MICROCRYSTALLINE SEMICONDUCTOR  
APPARATUS**

**Payment of Fee**

(Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p))

- ☐ A check in the amount of \_\_\_\_\_ is attached.
- ☒ The Director is hereby authorized to charge and credit Deposit Account No. 07-1180 as described below.
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Ronald W. Citkowski  
Reg. No. 31,005  
Gifford, Krass, Groh, Sprinkle,  
Anderson & Citkowski, P.C.  
280 N. Old Woodward Ave., Suite 400  
Birmingham, MI 48009  
248-647-6000

CC:

<b>INFORMATION DISCLOSURE CITATION</b> <i>(Use several sheets if necessary)</i>				Docket Number (Optional) <b>USS-18302/16</b>		Application Number <b>10/765,435</b>	
				Applicant(s) <b>Subhendu Guha et al.</b>			
				Filing Date <b>January 27, 2004</b>		Group Art Unit	

O I P E J C S E  
 MAY 04 2004  
 PATENT & TRADEMARK OFFICE

U.S. PATENT DOCUMENTS							
*EXAMINER INITIALS	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		4,600,801	7/15/1986	Guha et al.	136	249	
		5,977,476	11/2/1999	Guha et al.	136	249	
		6,274,461	8/14/2001	Guha et al.	438	478	
		6,368,944	4/9/2002	Okabe et al.	438	482	
		6,472,248	10/29/2002	Shiozaki et al.	438	97	
		6,521,883	2/18/2003	Isomura	250	214.1	

FOREIGN PATENT DOCUMENTS								
REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation		
						YES	NO	

OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>		
		Shah et al.: <u>Material and Solar Cell Research in Microcrystalline Silicon</u> ; "Solar Energy Materials and Solar Cells 78; pp. 469-491 (2003)

EXAMINER	DATE CONSIDERED
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.